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APPLICANT'S(S') INFORMATION  
DISCLOSURE STATEMENT

Applicant(s): Jaan Noolandi et al.

Filing Date: December 28, 2000

Group: 1743

## U.S. PATENT DOCUMENTS

Initial*		Document No.	Date	Name	Class	Subcl.	Filing Date
JS	AA	4,424,524	1/1984	Daniele	/	/	
	AB	4,509,826	4/1985	Araghi	/	/	
	AC	4,690,391	9/1987	Stoffel et al.	/	/	
	AD	4,712,018	12/1987	Stoffel et al.	/	/	
	AE	4,927,265	5/1990	Brownlee	/	/	
	AF	5,695,626	12/1997	Yeung et al.	/	/	
	AG	5,741,411	4/1998	Yeung et al.	/	/	
JS	AH	5,936,230	8/1999	Street	/	/	
	AI						
	AJ						
	AK						

## FOREIGN PATENT DOCUMENTS

		Document No.	Date	Country	Class	Subcl.	Translation?
	AL						
	AM						
	AN						
	AO						
	AP						

## OTHER ART

JS	AR	Amorphous Silicon Electronics, R.A. Street, Materials Research Society Bulletin, Volume XVII, Number 11, November 1992, pp. 70-76
	AS	website pages from <a href="http://bio.licor.com">http://bio.licor.com</a> , (4 pages), (printed 11/13/2000)
JS	AT	website pages from <a href="http://bio.licor.com">http://bio.licor.com</a> , (13 pages), (printed 11/17/2000)

Examiner:

Jeffrey Lewis

Date Considered:

3/10/02

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EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if in conformance and not considered. Include copy of this form with next communication to applicant.